# Consistent parameter extraction using different MOSFET models

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#### On the 'definitions' of the threshold voltage

- Surface potential based  $\phi_s = 2\phi_F + V_C$
- Qualitative: gate voltage at which significant drain current starts to flow
- Procedural based (details on next slide)

#### **Other approaches:**

- Splitting the threshold: define weak, moderate and strong inversion VTs
- Deconstructing the threshold: surface potential models don't use VT as parameter!

#### **The standard VT extraction methods**



# **PROBLEM:** missing link between extracted threshold and surface potential value!

A. Ortiz-Conde *et al*, "<u>Revisiting MOSFET threshold voltage</u> <u>extraction methods</u>", *Microelectronics Reliability*, 2012

#### **Current based definition of threshold 1**



MOSFET OPERATION: Drain current split into diffusion and drift components vs. gate voltage for a MOSFET operating in the linear region with  $V_{DS}=\phi_t/2=13$ mV.

#### **Current-based definition of threshold 2**

- **Sound modeling:** To accurately extract  $V_T$  it is essential that the MOSFET model includes the drift and diffusion transport mechanisms, both important near the threshold condition.
- Extraction methods based solely on the strong (SI) or weak (WI) inversion models are inherently inaccurate since to determine the threshold voltage (which is found between the SI and WI regions) experimental data are extrapolated from only one of these two operating regions.

#### **Current based definition of threshold 3**



M. A. Maher and C. A. Mead, "A physical charge-controlled model for MOS transistors," *Advanced Research in VLSI*, MIT Press

Take  $I_{drift} = I_{diff}$  to define the threshold.

$$Q'_{ITH} = -(C'_{ox} + C'_{b})\frac{kT}{q} = -nC'_{ox}\frac{kT}{q}$$

$$dv_{c} \leftarrow dv_{c} \leftarrow dv_{c} \leftarrow dv_{s} \leftarrow dv_$$

 $C'_{ox}$   $C'_{b}$  are the oxide and depletion capacitances per unit area

The carrier charge density at threshold is the effective channel capacitance per unit area times the thermal voltage, or the thermal charge per unit area

## **Charge-based all-region MOSFET model 1**



 $C'_{ox}$   $C'_{b}$  oxide and depletion capacitances per unit area

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## **Charge-based all-region MOSFET model 2**

$$I_D = I_F - I_R = I_S \left[ i_f - i_r \right]$$

 $q'_{I} = \frac{Q'_{I}}{-nC'_{ox}\phi_{t}}$  Normalized inversion charge density

$$i_{f(r)} = q'_{IS(D)}^{2} + 2q'_{IS(D)} \Longrightarrow q'_{IS(D)} = \sqrt{1 + i_{f(r)}} - 1$$



Diffusion Drift

Threshold condition at the source:

$$q'_{IS} = 1 \rightarrow i_f = 3$$

#### **Difference between the EKV approach and ours**

IEEE TRANSACTIONS ON ELECTRON DEVICES, VOL. 58, NO. 11, NOVEMBER 2011

#### An Adjusted Constant-Current Method to Determine Saturated and Linear Mode Threshold Voltage of MOSFETs

Antonios Bazigos, *Member, IEEE*, Matthias Bucher, *Member, IEEE*, Joachim Assenmacher, Stefan Decker, Wladyslaw Grabinski, *Senior Member, IEEE*, and Yannis Papananos, *Senior Member, IEEE* 

IADLE I NORMALIZATION FACTORS

| Quantity    | Normalization Factor                        |
|-------------|---|
| Potential   | $U_T = \frac{kT}{q}$                        |
| Charge      | $Q_0 = 2nU_T C_{OX} WL$                     |
| Current     | $I_{SPEC} = 2nU_T^2 \mu C_{OX} \frac{W}{L}$ |
| Conductance | $G_0 = \frac{I_{SPEC}}{U_T}$                |
| Capacitance | $C_0 = \frac{Q_0}{U_T}$                     |

k is Boltzmann constant, T is temperature in Kelvin, q is the electron charge, n is the slope factor,  $\mu$  is the mobility,  $C_{OX}$  is the oxide capacitance per unit area, W and L are the effective width and length of the MOS transistor.

Our approach  $I_{TH} = 3I_{S} = 1.5(W/L)\mu C'_{ox}n\phi_{t}^{2}$ EKV  $I_{TH} = 0.608I_{SPEC} = 1.216(W/L)\mu C'_{ox}n\phi_{t}^{2}$ 

$$I_{\text{TH-sat}} = I_{D|V_P=V_S} = \left(q_{s|V_P=V_S}^2 + q_{s|V_P=V_S}\right) I_{\text{SPEC}}$$
$$= 0.608 I_{\text{SPEC}}, \quad \text{where } q_{s|V_P=V_S} = F^{-1}(0). \quad (6)$$

Then, threshold voltage  $V_{\text{TH}}(V_{\text{TB}})$  in saturation is determined as the value of  $V_{GS}(V_G)$  for which the drain current is equal to approximately  $0.6I_{\text{SPEC}}$ .

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## $g_m/I_D V_T$ -extraction procedure





$$\frac{g_m}{I_D} = \frac{1}{I_D} \frac{dI_D}{dV_G} = \frac{g_{ms} - g_{md}}{nI_D} = \frac{2}{n\phi_t \left(\sqrt{1 + i_f} + \sqrt{1 + i_r}\right)}$$
$$\frac{g_m}{I_D}\Big|_{V_{DS} \to 0} = \frac{1}{n\phi_t \sqrt{1 + i_f}}$$

Thus, at threshold ( $i_f = 3$ )  $g_m/I_D$  is  $\frac{1}{2}$  of its maximum value ( $n=n(V_G)\cong$  constant)

For  $V_{DS} = (1/2)kT/q$ ,  $g_m/I_D$ =0.531  $(g_m/I_D)_{max}$  and  $I_D$ =0.88\* $I_S$ 

# $g_m/I_D V_T$ -extraction for a 3.5/0.5 nMOSFET simulated by BSIM6



#### **CMOS** inverter at VDD = 150 mV



#### **CMOS inverter at VDD = 100 mV**



#### **CMOS** inverter at VDD = 50 mV



# **Ring oscillator**



# Transient simulation of the ring oscillator





#### Transient time analysis: BSIM6 vs. WI model



#### Conclusions

- The fundamental problem in switching between transistors models is to consistently determine the parameters of the different models.
- The gm/ID procedure in the linear region allows determining accurately the most critical MOS parameters: the threshold voltage, the slope factor, and the specific current.
  - Examples comparing simulations carried out with BSIM6 model and a simple weak inversion MOSFET model show good agreement for very low voltage circuits.

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